

FORM PTO 1449 (modified) U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE LIST OF REFERENCES CITED BY APPLICANT(S) <i>(Use several sheets if necessary)</i>		ATTY DOCKET NO. 35.G2738	APPLICATION NO. 09/749,727
APPLICANT YOICHI ANDO		FILING DATE December 28, 2000	
GROUP N.Y.A.			

U.S. PATENT DOCUMENTS							
*EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE	

FOREIGN PATENT DOCUMENTS							
DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES NO OR ABSTRACT		

OTHER DOCUMENT(S) (Including Author, Title, Date, Pertinent Pages, Etc.)	
	M. Hartwell et al.; "Strong Electron Emission From Patterned Tin-Indium Oxide Thin Films"; INTERNATIONAL ELECTRON DEVICES MEETING; 1975, pp. 519-521.
	G. Dittmer; "Electrical Conduction and Electron Emission of Discontinuous Thin Films"; THIN SOLID FILMS; 1972, pp. 317-328.
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	C.A. Spindt et al.; "Physical Properties of Thin-Film Field Emission Cathodes with Molybdenum Cones"; JOURNAL OF APPLIED PHYSICS; Vol. 47, No. 12, December 1976, pp. 5248-5263.
	H. Araki et al.; "Electroforming and Electron Emission of Carbon Thin Films"; J. Vac. Soc. Japan, 26 (1983), pp. 22-29; (with English Abstracts on p. 22).
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*EXAMINER Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

U.S. DEPARTMENT OF COMMERCE
PATENT AND TRADEMARK OFFICE

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U.S. PATENT DOCUMENTS

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ny	5,532,548	7/96	Spindt et al.	313	422	
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	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES/NO/ OR ABSTRACT
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ny	WO 98/28774	7/2/98	PCT			
ny	WO 99/03126	1/21/99	PCT			
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ny	04-163833	6/9/92	Japan			Abstract
ny	4-284340	10/8/92	Japan			Abstract

OTHER DOCUMENT(S) (Including Author, Title, Date, Pertinent Pages, Etc.)

EXAMINER	Glenn Zimmerman	DATE CONSIDERED	1-29-03
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